

Metal evaporation study using the GANIL high temperature oven for intense metal ion beamsproduction.

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Abstract

A new resistive oven dedicated to the production of metal ion beams using ECR ion sources has been developed at GANIL [1]. It aims to produce beams such as 58Ni^{q+}, 50Ti^{q+}, 50V^{q+} or 238U^{q+} with ECR4 ion source on cyclotrons injectors and with Phoenix V3 ion source on Spiral 2 facility. Typical intensity about 1.2 10¹³ pps is requested for the Super Separator Spectrometer (S3). Evaporated atom fluxes and their angular distributions have been measured on a dedicated test bench thanks to a quartz microbalance. These investigations were carried out using three crucibles with various exit caps geometries for which the fluxes and angular distributions display distinct behaviors. Based on those results crucible will be designed to obtain a high flux of atoms while minimizing the losses of atoms on the ion source chamber. Experimental results and crucible designs will be discussed.

Objectives

High intensity beams productions : ⁵⁸Ni^{N+}, ⁵⁰Ti^{N+}, ⁵⁰V^{N+} or ²³⁸U^{N+}...

> With **Phoenix V3** ion source on **Spiral 2** facility: **1.2E13 pps** requested for **S3**.

> With ECR4 ion source on GANIL cyclotrons injectors

Requested temperatures			
Element	T fusion	T (10 ⁻² mbar)	
	°C	°C	
V	1910	1826	
Ti	1668	1728 (liquid)	
Ni	1455	1505 (liquid)	
Со	1495	1517 (liquid)	
U	1132	2100 (liquid)	
UO ₂	2827	1990	

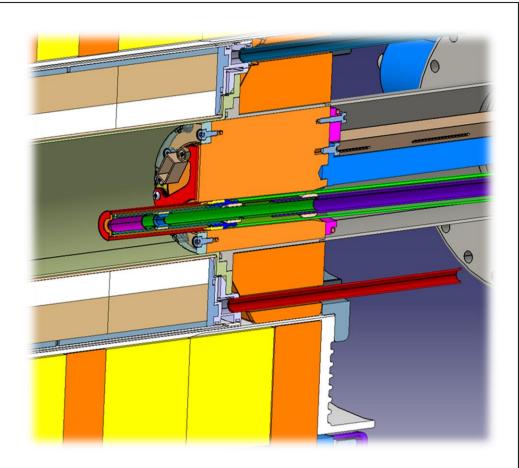
Resistive oven.

External diameter: **Φ 20**. Cylindrical resistor in the axis of the magnetic field \rightarrow no Laplace forces



The	crucible	
4	25	
6		
Cru	cible in WL20	
170	mm ³	

The resistor



To be integrated in Phoenix V3

> Intense **Uranium beams** development

Tube of Rhenium 0.05 mm thick made with a sheet melted by Laser



Stainless steel rod

Temperature calibration

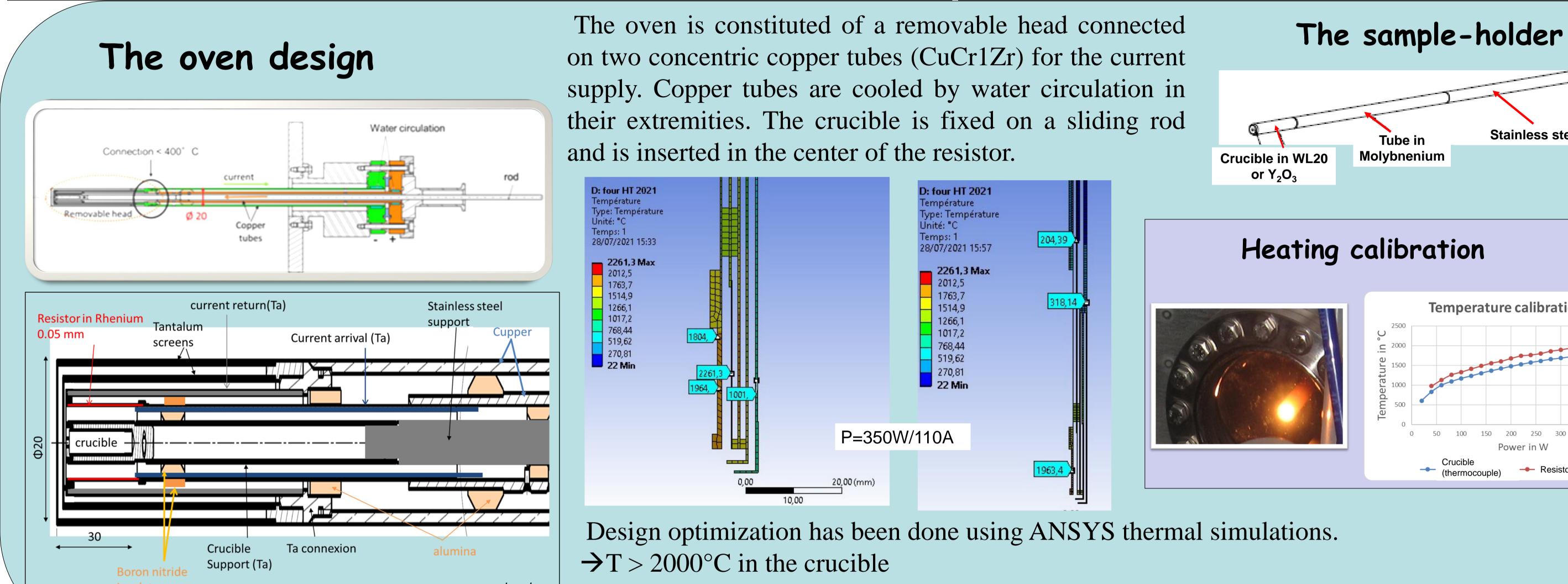
Power in V

Resistor (pyrometer)

Crucible

Tube in

Molybnenium



insulator

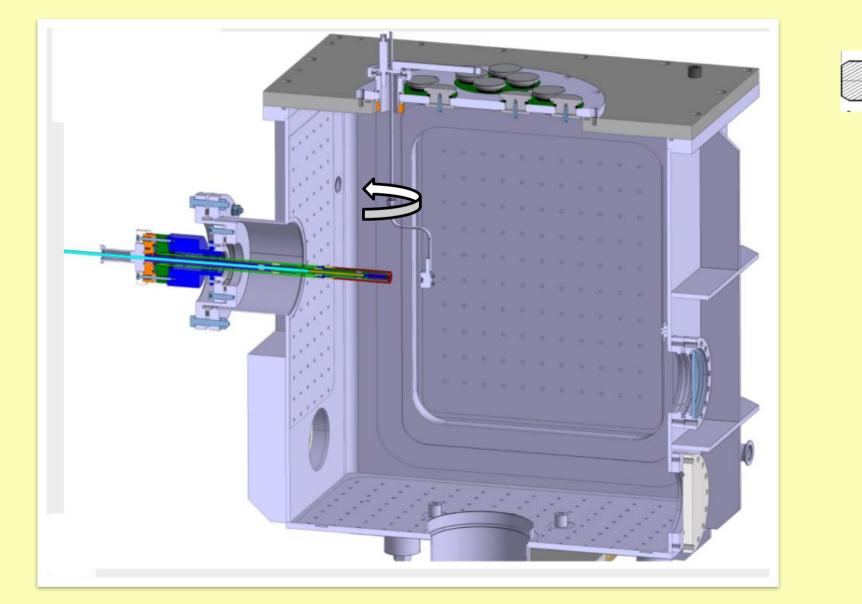
compressed scale

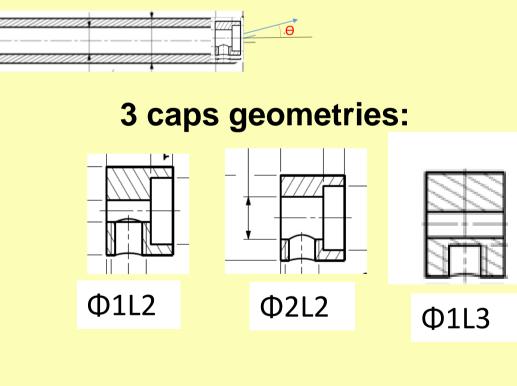
 \rightarrow T < 300°C at the junction between the removable head and the cooled copper current supplies.

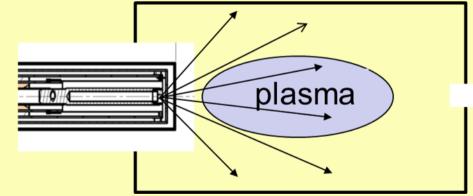
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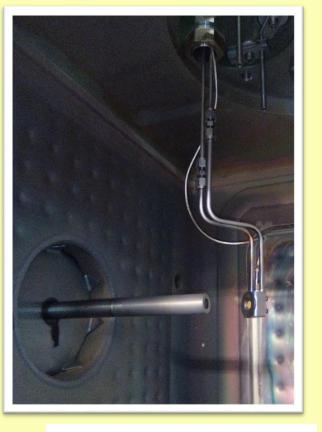
Evaporation measurement

A quartz microbalance (Q-pod / 6 MHz quartz crystal) on a cooled rotating support \rightarrow flux in ng/cm²/s at each angle.







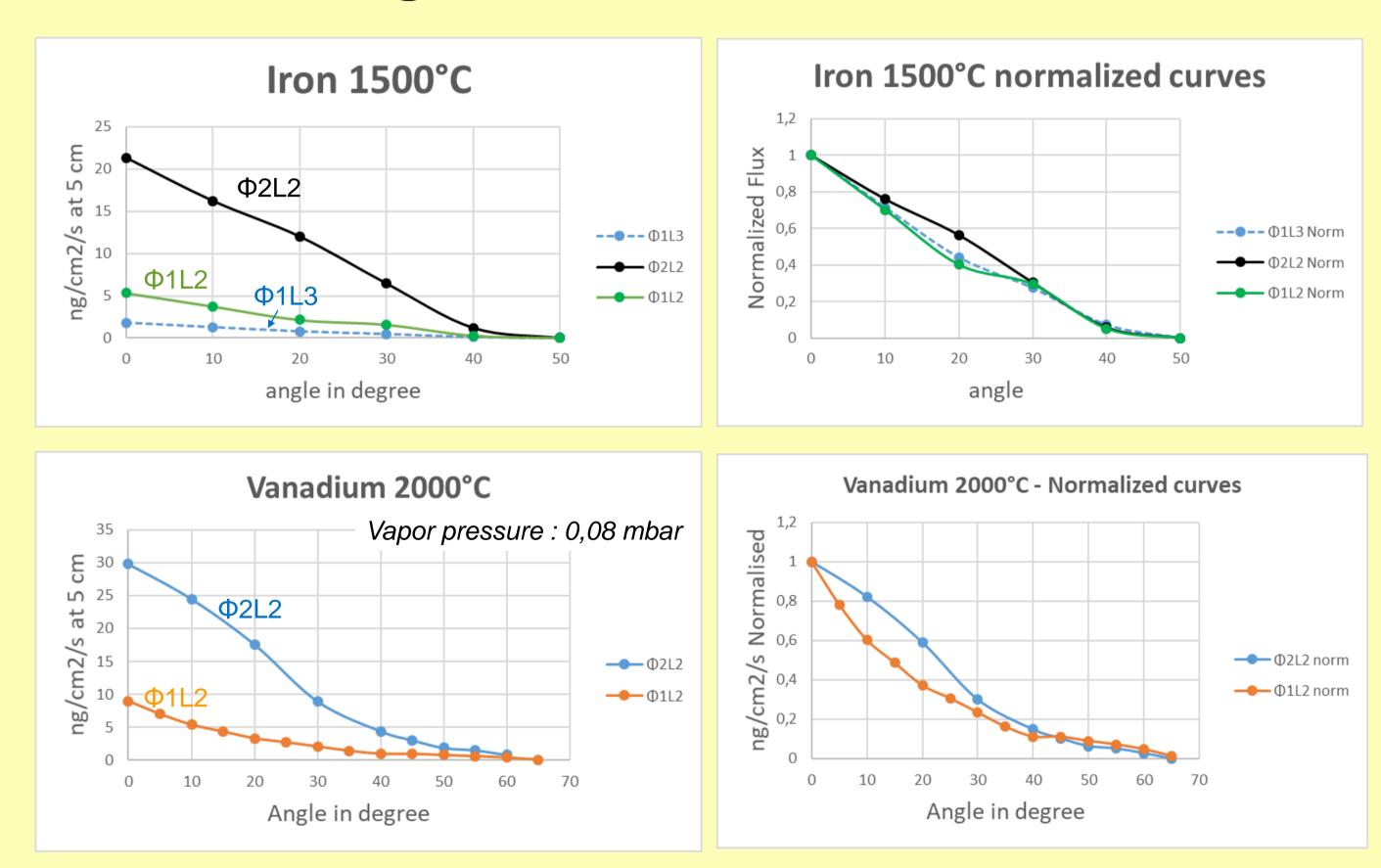


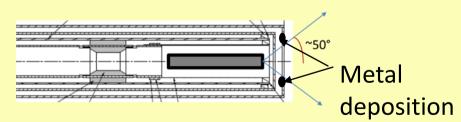
Quartz Microbalance

Flux in at. s^{-1} in a α angle cone: $\phi_{\alpha} = 2\pi D^2 \int \sin\theta f(\theta) d\theta$

D: distance crucible exit/quartz detector

Angular distributions





 $f(\theta)$: number of at/cm2/s on the quartz at an angle θ .

Vanadium 2000°C	Flux in 20°	Fraction emitted in the 20° cone
Сар Ф2L2	2,3.10 ¹⁵	~ 37 %
Сар Ф1L2	5,2.10 ¹⁴	~ 33 %

- Vanadium consumption rate deducted from flow measurements: **1.9 mg/hour** at the beginning – **0.85 mg/hour** after 19 hours
- Real consumption weighed after 22 hours of heating: 2.3 mg/hour (losses onto screens)
- The oven reliability at the requested temperature for Vanadium has been confirmed. • The hole $\Phi 2$ cap seems the best choice (larger flow and no big differences on losses at large angles)

Vanadium beams production with ECR4 on Ganil injector

- Validation of the oven integrated in ECR4 on Ganil Injector for Vanadium beam production.
- Support gas: Helium
- Oven heating power : ~ **330W** / 111A (**T > 2000°C**)
- Vⁿ⁺ beam up to **120 μAe (V⁷⁺)**
- Duration limited by the deformation of the sample-holder

Underway \rightarrow new test for long duration using modified sampleholder: support tube in Molybdenium instead of Tantalum.

